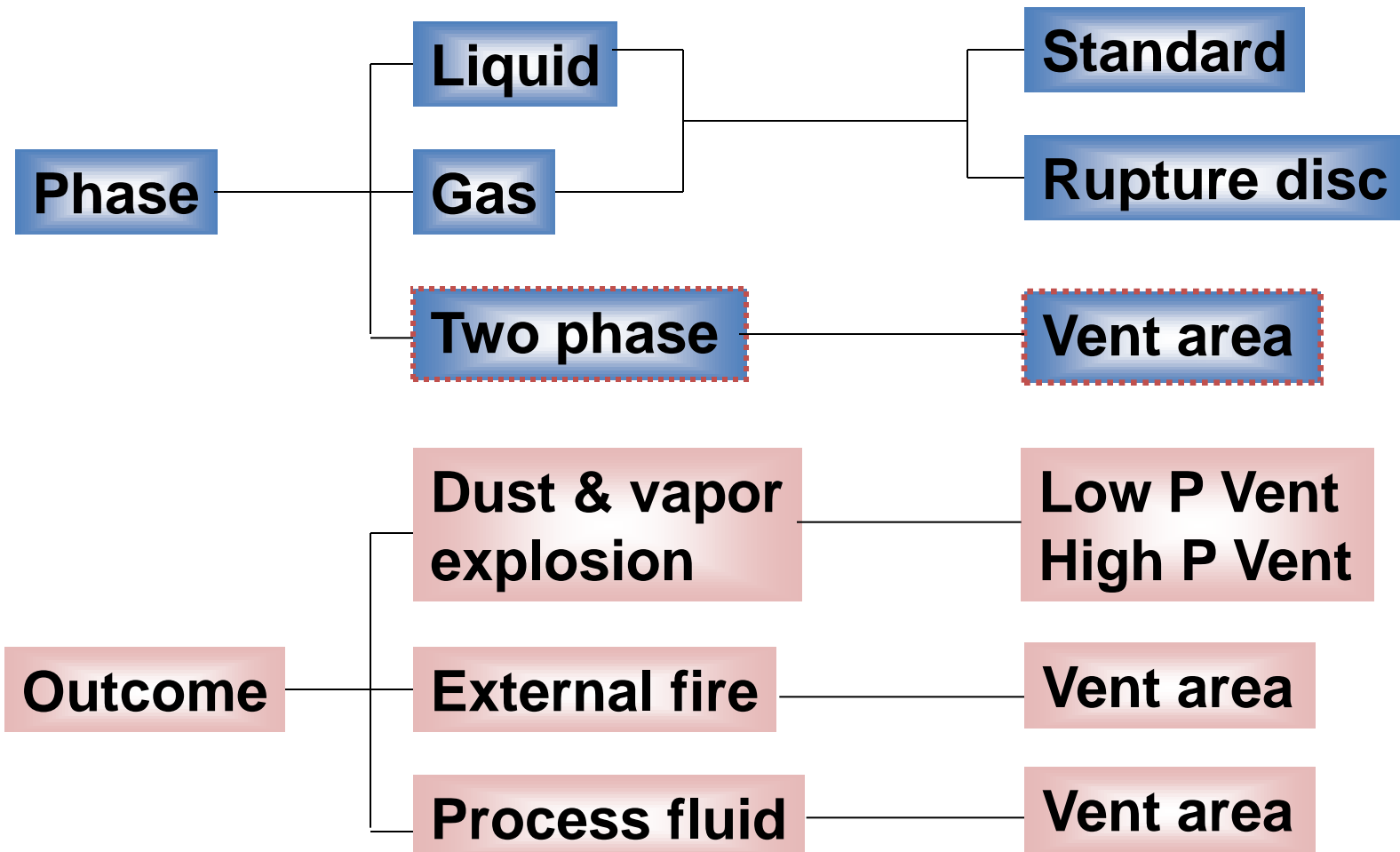


Relief System Sizing

Calculating Relief Size I

- **Conventional spring-operated reliefs in liquid or vapor-gas service**
- **Rupture disc in liquid or vapor-gas service**
- **Two-phase flow during runaway rxn**
- **Reliefs for dust and vapor explosion**
- **Reliefs for external fire**
- **Reliefs for thermal expansion of process fluid**

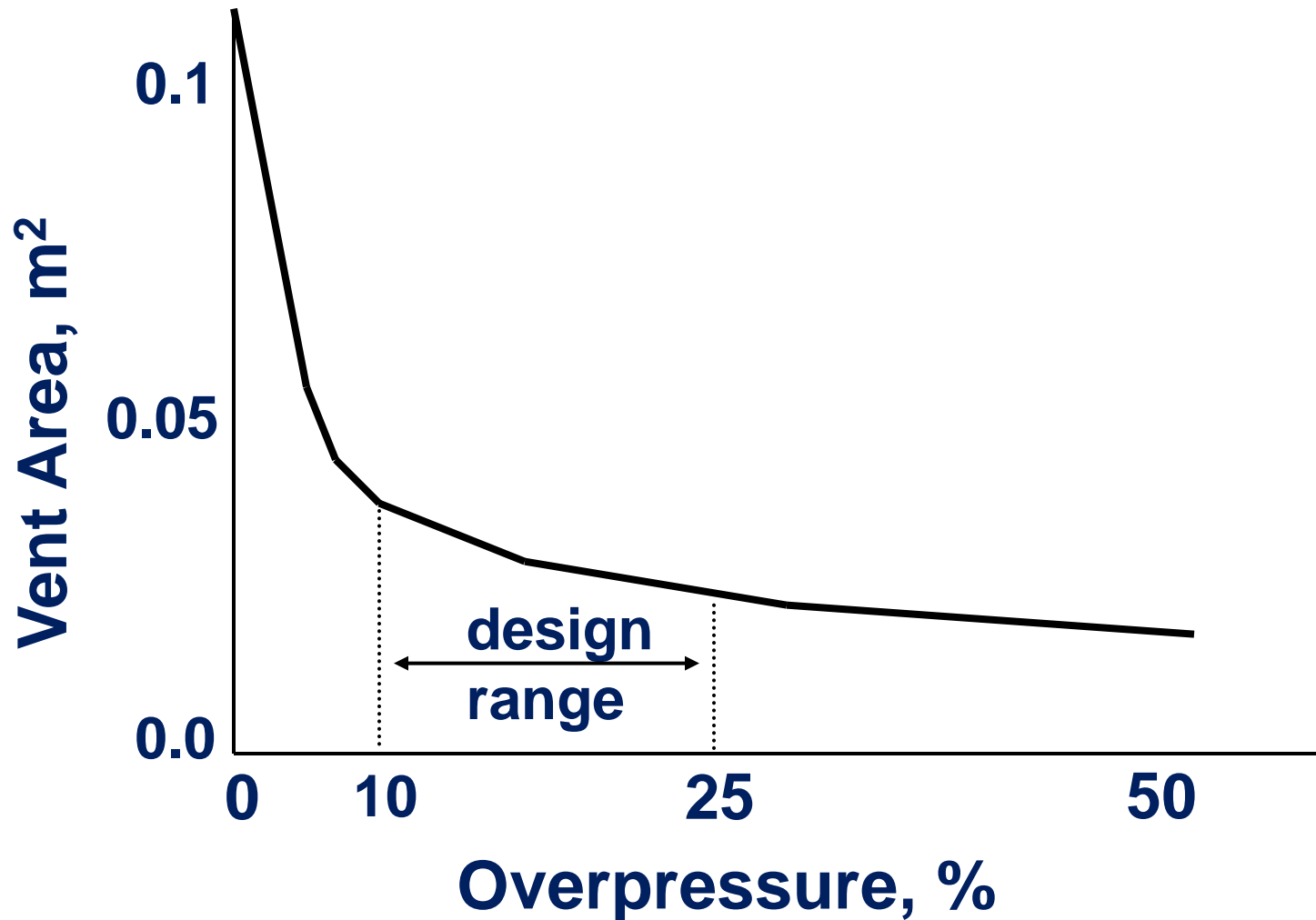
Calculating Relief Size II



Relief Area Requirements

- **Minimum flow to hold valve seat in open position: 25-30 % of maximum flow**
 - **Low flow can lead to rapid opening and closing (*chattering*)**
- **Overpressures are designed to be 10 to 25 % above set pressures to prevent excessive vent sizes**
- **To hold pressures near the set pressures would require much larger vent sizes**

Required Vent Area, 2-f Flow



Spring Relief Area for Liquids

Assume orifice flow through the valve port:

$$Q_v = \bar{u} A = A C_o \sqrt{\frac{2g_c \Delta P}{\rho}}$$

Eqn 4-6, p. 114

$$A = \frac{Q_v}{\bar{u}} = \left[\frac{\text{in}^2 (\text{psi})^{1/2}}{38.0 \text{ gpm}} \right] \frac{Q_v}{C_o} \sqrt{\frac{\rho / \rho_{ref}}{\Delta P}}$$

\bar{u} is the liquid velocity through the spring relief,
 C_o is the discharge coefficient,
 ΔP is the pressure drop across the relief, and
 ρ is the liquid density

Computed Area for Liquids

- ✚ ***A* is *computed area* for device sizing as contrasted to *effective valve area* during use**
- ✚ **Max pressure in the API equation is 25 % above the set pressure**
- ✚ **For C_0 use the conservative value of 0.61 unless more information is available**
- ✚ **K_v , K_p , K_b are correction factors for use of the API equation with various liquid viscosities, maximum pressures, and backpressure.**

Spring Relief Area for Liquids

API correction factors included for wide applications:

$$A = \left[\frac{\text{in}^2 \text{psi}^{1/2}}{38 \text{gpm}} \right] \frac{Q_v}{C_o K_v K_p K_b} \sqrt{\frac{\rho / \rho_{ref}}{1.25 P_s - P_b}}$$



A is the computed relief area (in²),

Q_v is the volumetric flow through the relief (gpm),

C_o is the discharge coefficient (unitless),

K_v is the viscosity correction (unitless),

K_p is the overpressure correction (unitless),

K_b is the backpressure correction (unitless),

(ρ/ρ_{ref}) is the specific gravity of the liquid (unitless),

P_s is the gauge set pressure (lb_f/in²)

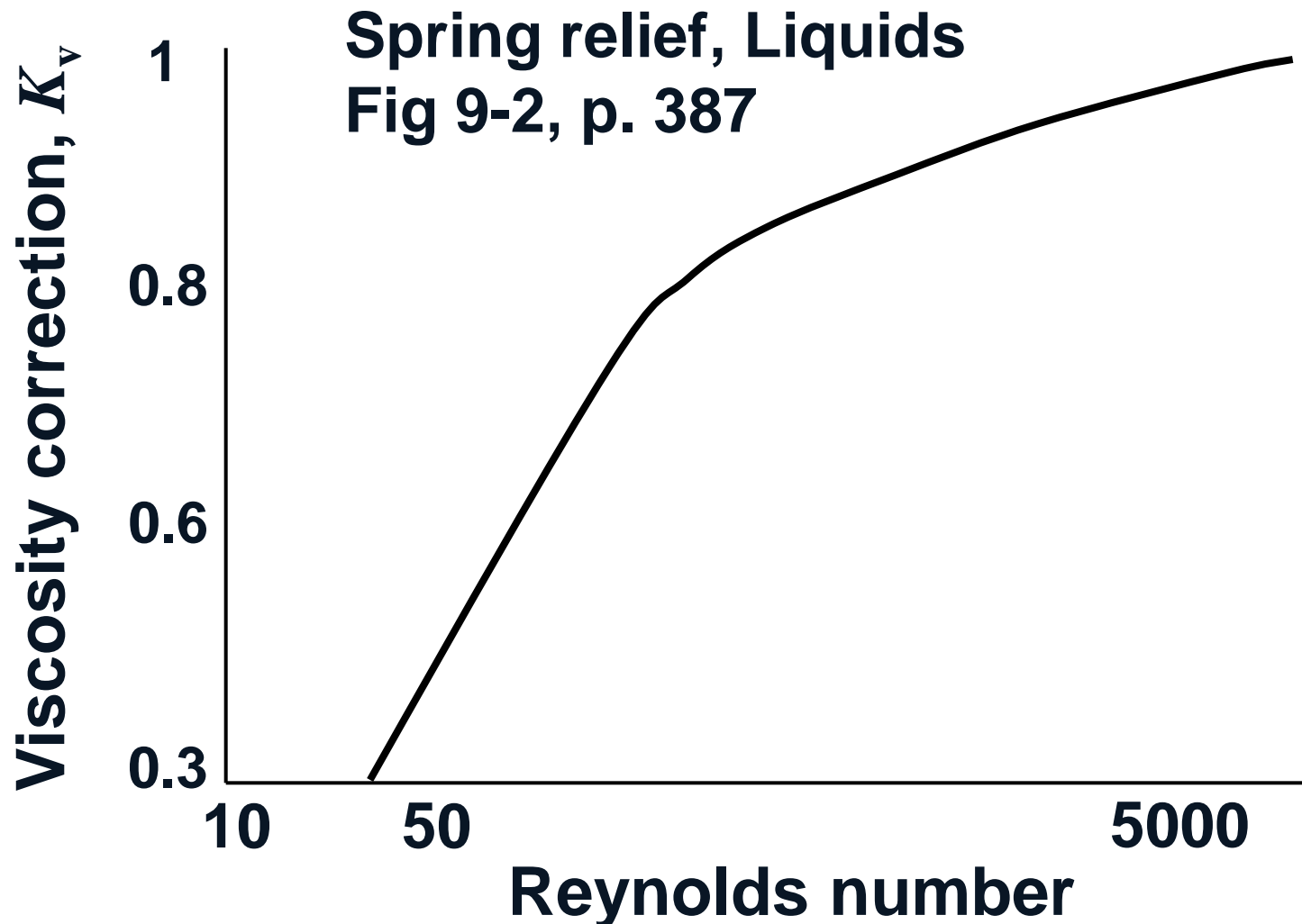
P_b is the gauge backpressure (lb_f/in²)

Correct Area for Viscosity: K_v

- ✚ Higher the viscosity the higher the friction losses through the valve
- ✚ Higher the viscosity, the smaller the Reynolds number, Re , and smaller the K_v and therefore the larger the required A
- ✚ Re usually is $> 5,000$. Then K_v is ~ 1 .
- ✚ For low Re , K_v is a strong function of Re

$$K_v = \sqrt{\frac{1}{\frac{170}{Re} + 0.98}}$$

Viscosity Correction Factor: K_v

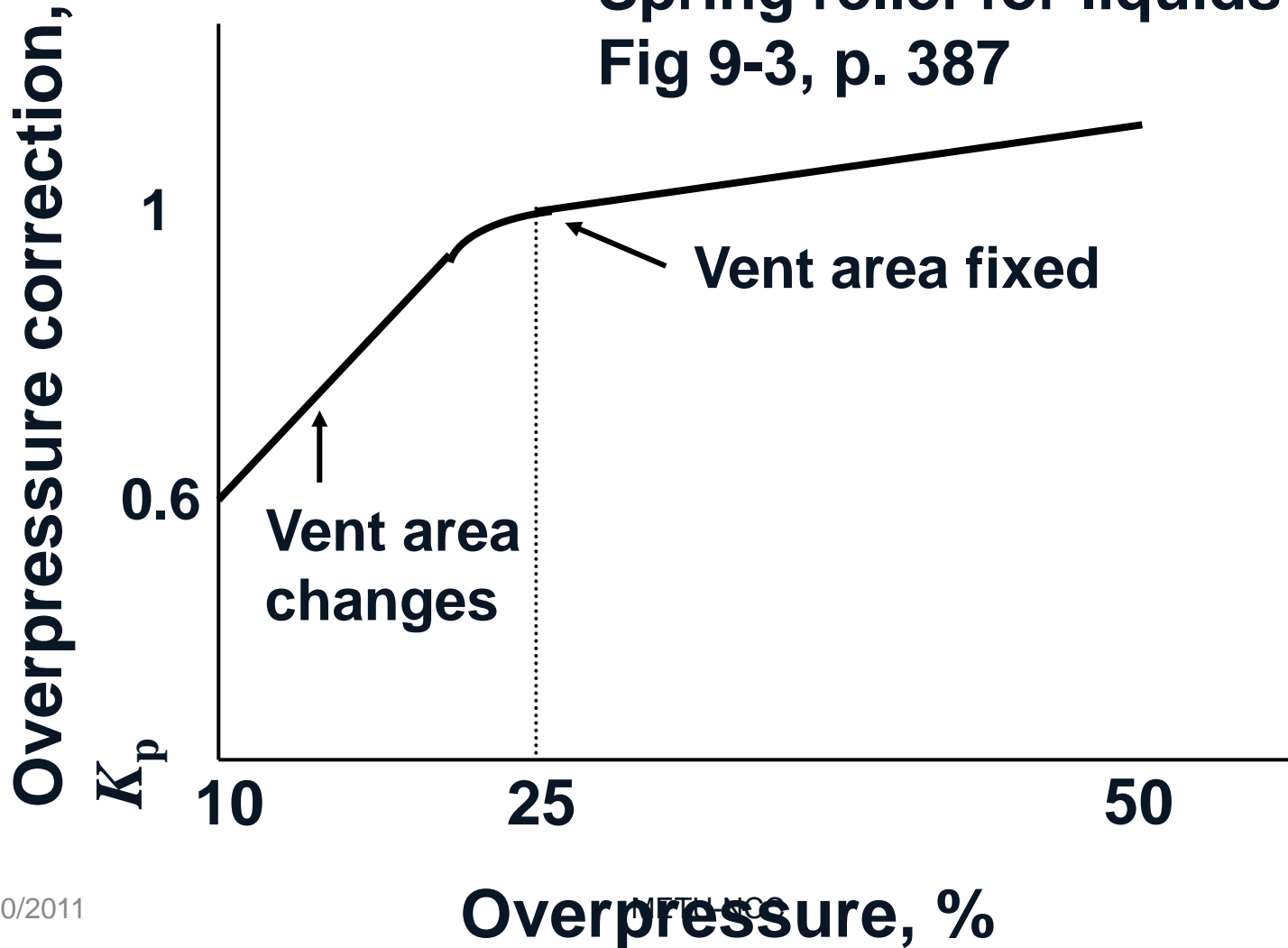


Correct A for Overpressure: K_p

- ✚ **$1.25 P_s - P_b = \Delta P$ for 25 % overpressure (OP); use a correction factor, K_p , for OP within 10 - 50 %**
- ✚ **OP correction factor: $K_p = 1$ for 25 % OP**
- ✚ **Above 25 %, the vent area is fixed, so flow rate change only with pressure drop: K_p is a weak function of pressure in this range**
- ✚ **Below 25 %, the vent area changes with pressure, so flow rate changes with pressure drop and with area: K_p is a strong function of pressure in this range.**

Overpressure Correction: K_p

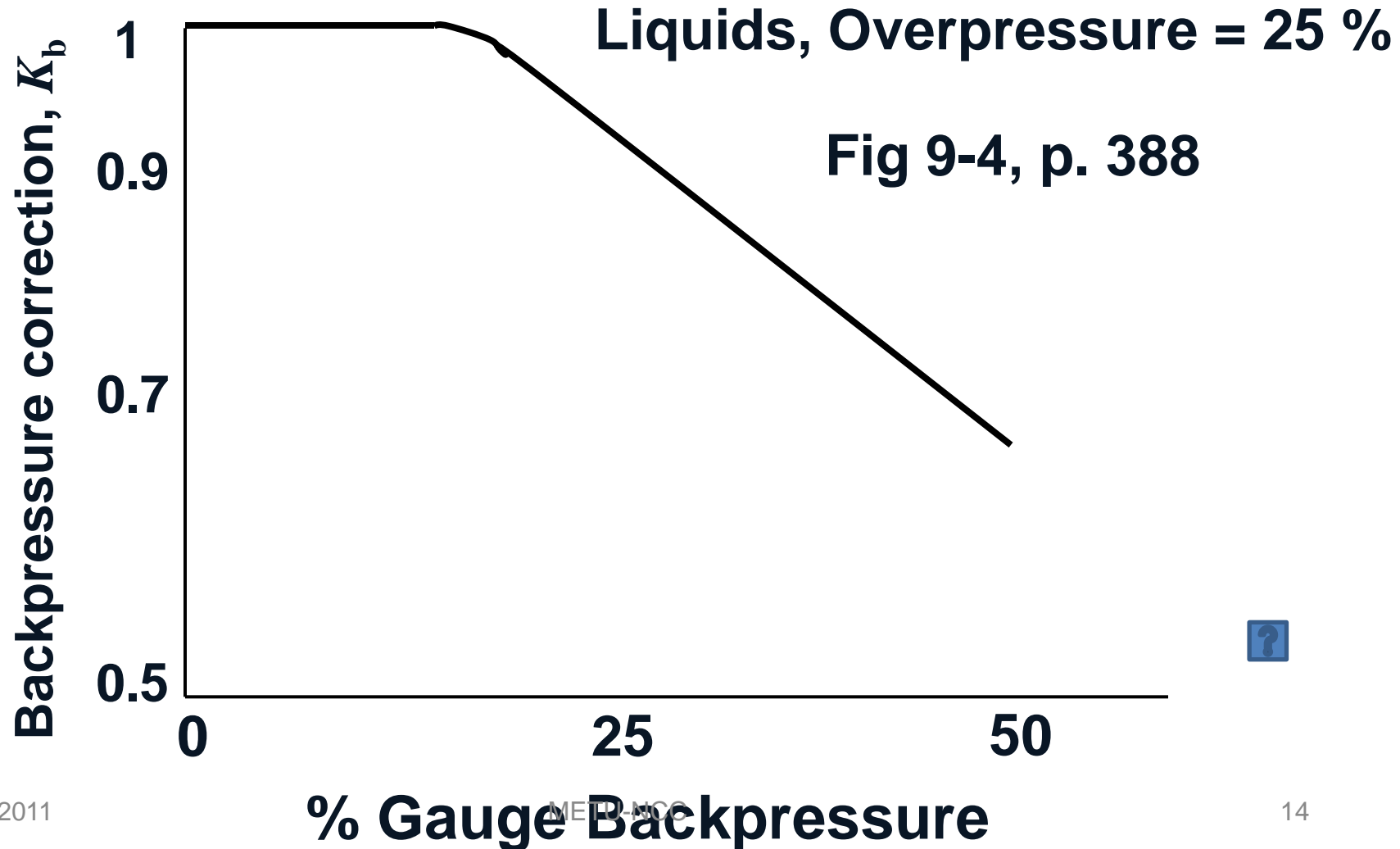
Spring relief for liquids
Fig 9-3, p. 387



Correct Area for Backpressure: K_b

- ✚ P_b in basic API equation corrects for effects of backpressures in conventional valves (set pressure and flow rate)
- ✚ Higher the backpressure, the lower the flow: larger the calculated required area, A
- ✚ For balanced bellows valves, a correction factor, K_b , must be included because the set pressure does not increase as backpressure increases
- ✚ The higher the backpressure, the smaller the K_b and the larger the required A for a given Q_v
- ✚ Ex 9-1, p 388 relief sizing

K_b for Balanced-Bellows Reliefs



Spring Relief Valves for Gases

In general, flow is critical with $P_{ch} > P_{ext}$:

$$(Q_m)_{ch} = C_o A P \sqrt{\frac{\gamma g_c M}{R_g T} \left(\frac{2}{\gamma+1} \right)^{(\gamma+1)/(\gamma-1)}} \quad \text{Eqn 4-50} \\ \text{p. 133}$$

$$A = \frac{Q_m}{C_o \chi K_b P} \sqrt{\frac{T z}{M}} \quad \begin{array}{l} z, \text{ compressibility factor} \\ P, \text{ max absolute discharge} \\ \text{pressure} \end{array}$$

$$\chi = \sqrt{\frac{\gamma g_c}{R_g} \left(\frac{2}{\gamma+1} \right)^{(\gamma+1)/(\gamma-1)}}$$



Vent Area Equation for Gases

✚ Separate K_b correction for each valve type:

- Standard valves, Fig 9-5, balanced bellows, Fig 9-6
- For larger backpressure, K_b smaller and A larger



✚ C_o : if not known use 0.975

✚ M is average molecular weight

✚ P is the maximum absolute relieving pressure:

$$P = P_{\max} + 14.7$$

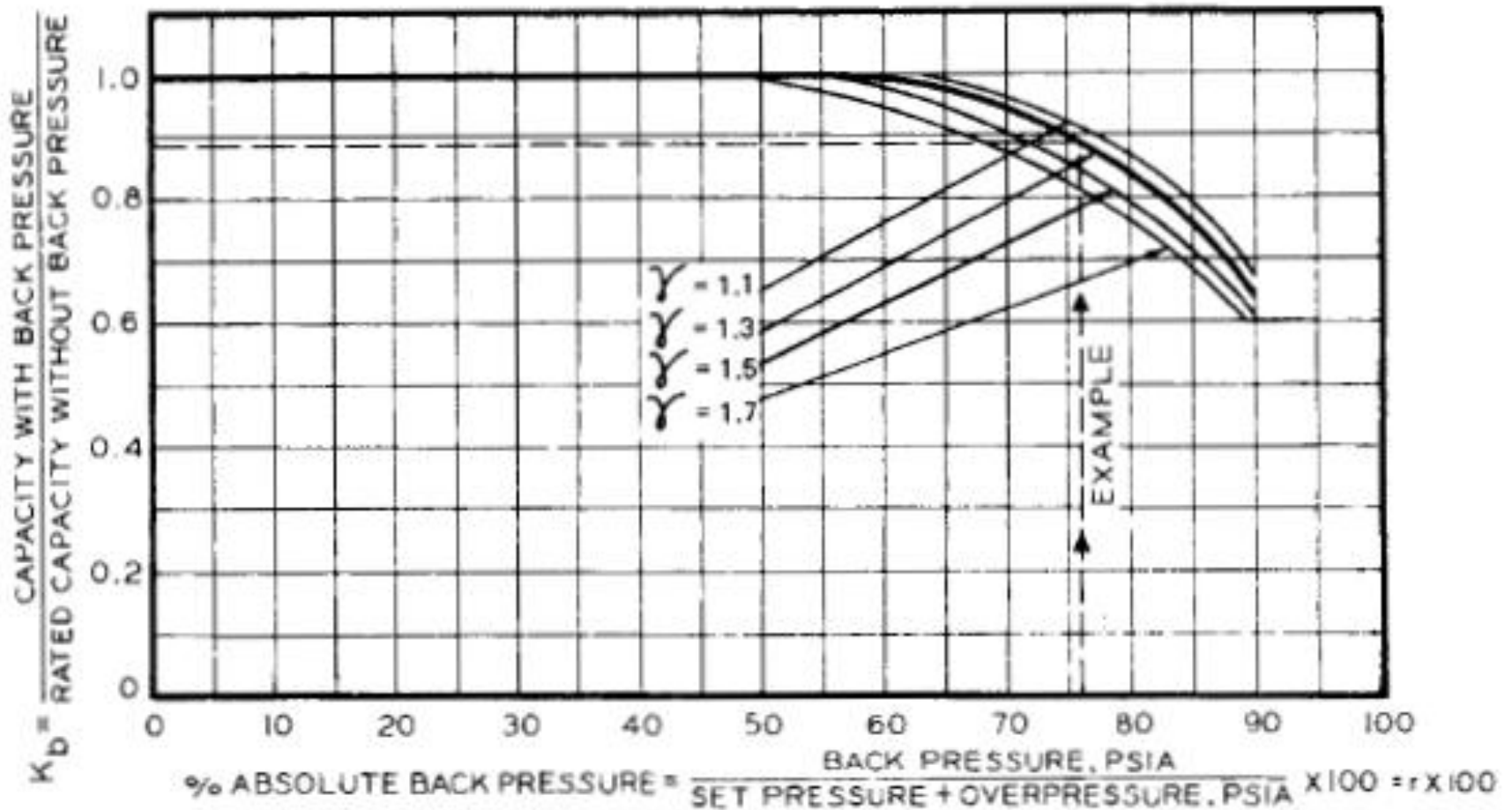
✚ ASME safety guidelines, P_s = gauge set pressure:

$$P_{\max} = 1.1P_s, \text{ unfired vessels}$$

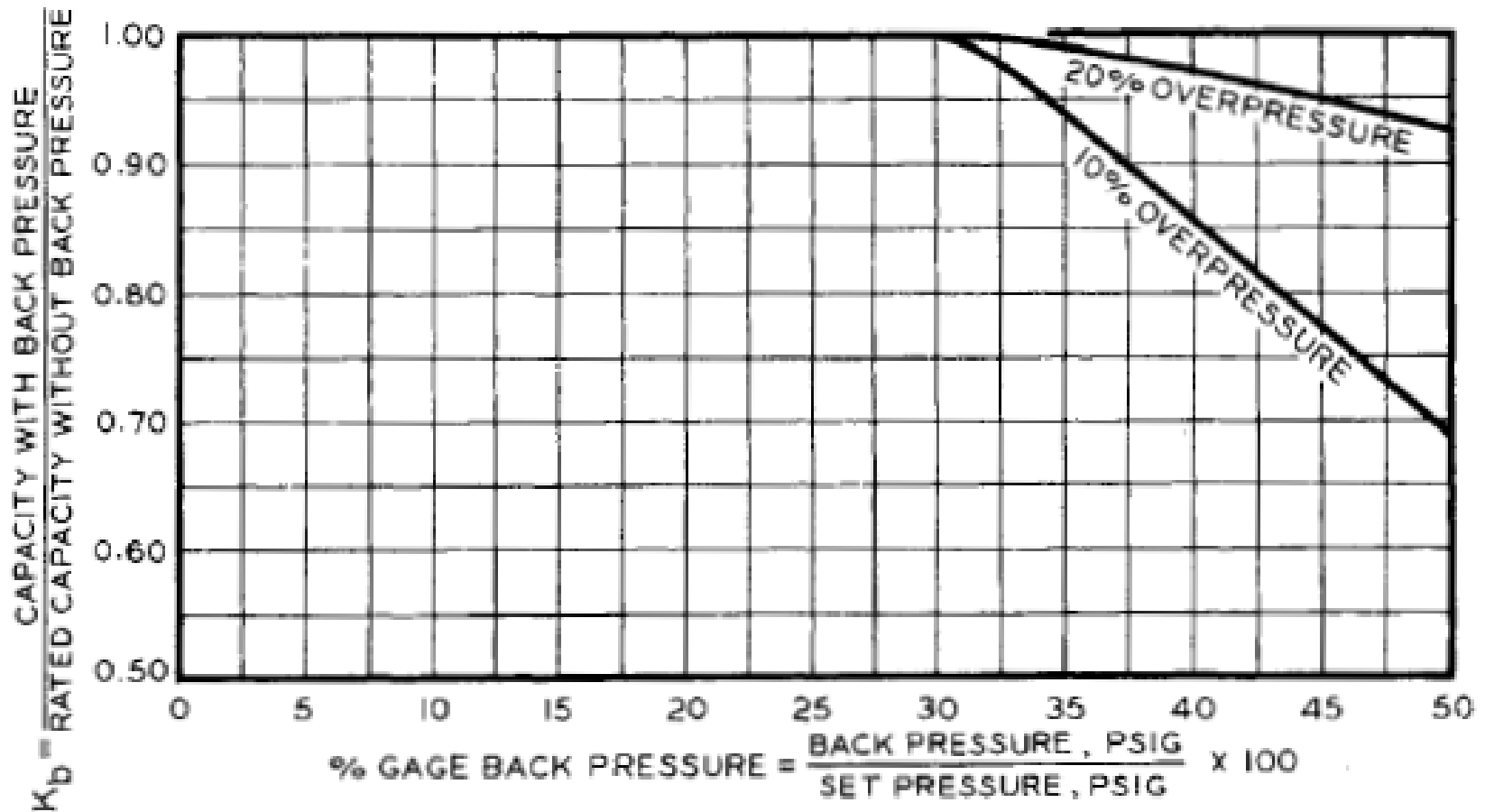
$$P_{\max} = 1.2P_s, \text{ vessels exposed to fire}$$

$$P_{\max} = 1.33P_s, \text{ piping, Ex 9-2, p 392}$$





Backpressure correction K_b for conventional spring-type reliefs in vapor or gas service. Source: API RP 520



Backpressure correction K_b for balanced-bellows reliefs in vapor or gas service. Source: API RP 520



Rupture Disks for Liquids

- ✚ Use expression for spring relief valves for liquids
 - Discharge directly to atmosphere or short piping:

$$A = \left[\frac{\text{in}^2 (\text{psi})^{1/2}}{38.0 \text{ gpm}} \right] \frac{Q_v}{C_o} \sqrt{\frac{\rho / \rho_{ref}}{\Delta P}} \quad \text{Eqn 9-3, p. 385}$$

- ✚ Discharge to a relief system:
- ✚ Flow through the system of pipes and other components must be analyzed as considered in study of source terms.

Rupture Disks for Gases

- ✚ Use expression for spring relief valves for gases
- ✚ For low backpressure levels with no K_b factor:

$$A = \frac{Q_m}{C_o \chi P} \sqrt{\frac{T z}{M}} \quad \text{Eqn 9-13, p. 394}$$

Assumes $C_o = 1$

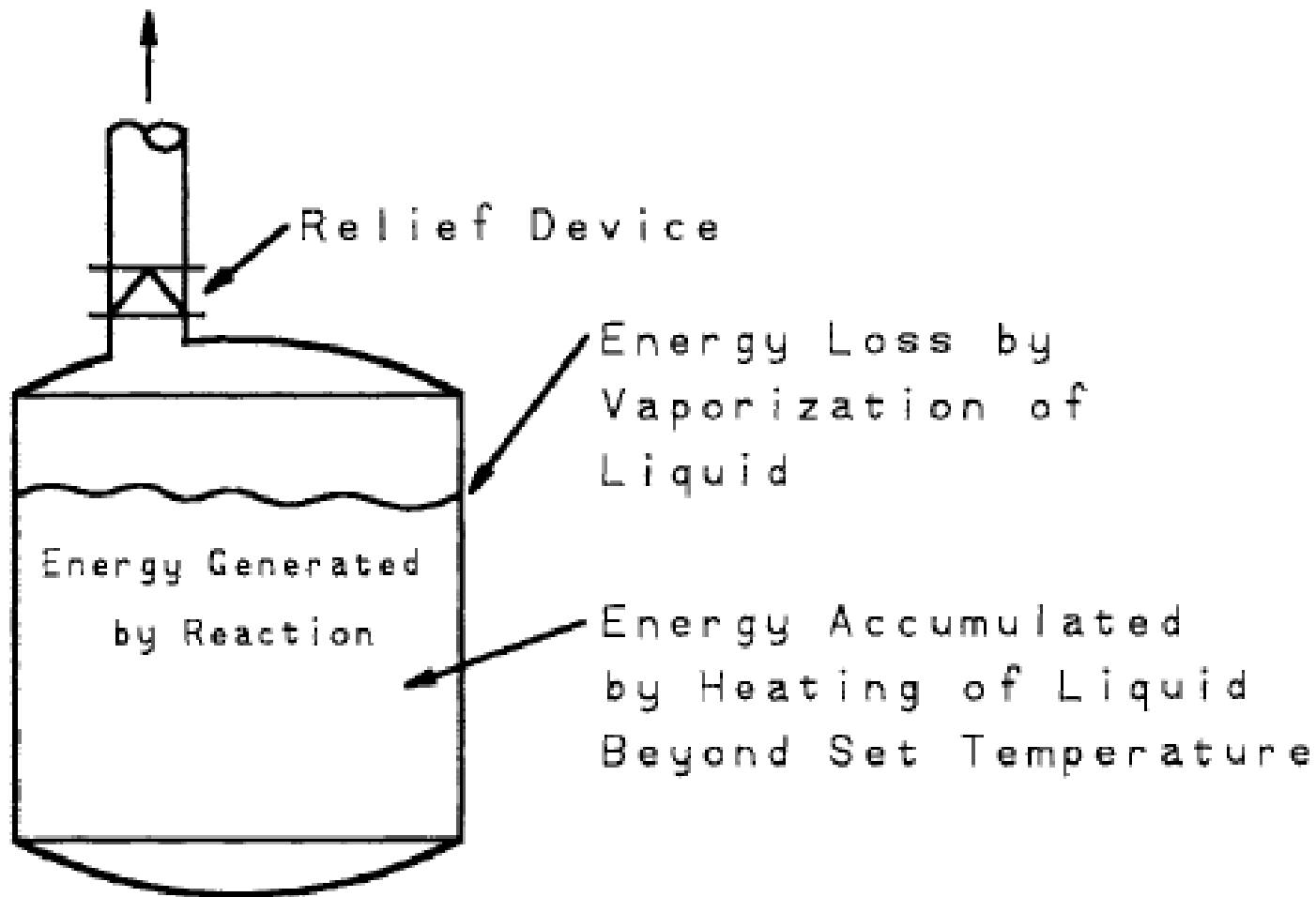


- ✚ For significant backpressure levels as into a containment system:
 - Analyze discharge and flow through the entire containment system. Ex 9-3,4, p 395

Two-Phase Relief Behavior

- ✚ Choked, two-phase flow through relief orifice
- ✚ Two-phase flow through containment system
- ✚ Runaway generally includes flashing during relief; ΔH_v removed (reaction is *tempered*)
- ✚ Reactor system, large vol/area, ~ *adiabatic*
- ✚ Energy removal only by vaporization and discharge

2-Phase Flow



A tempered reaction system

Two-Phase Mass Discharge

- ✚ Liquids at their saturation pressure, saturation temperature, T_s , the two-phase mass flow rate:

$$Q_m = \frac{\Delta H_v A}{v_{fg}} \sqrt{\frac{g_c}{T_s C_p}}$$

Eqn 4-104, p. 156

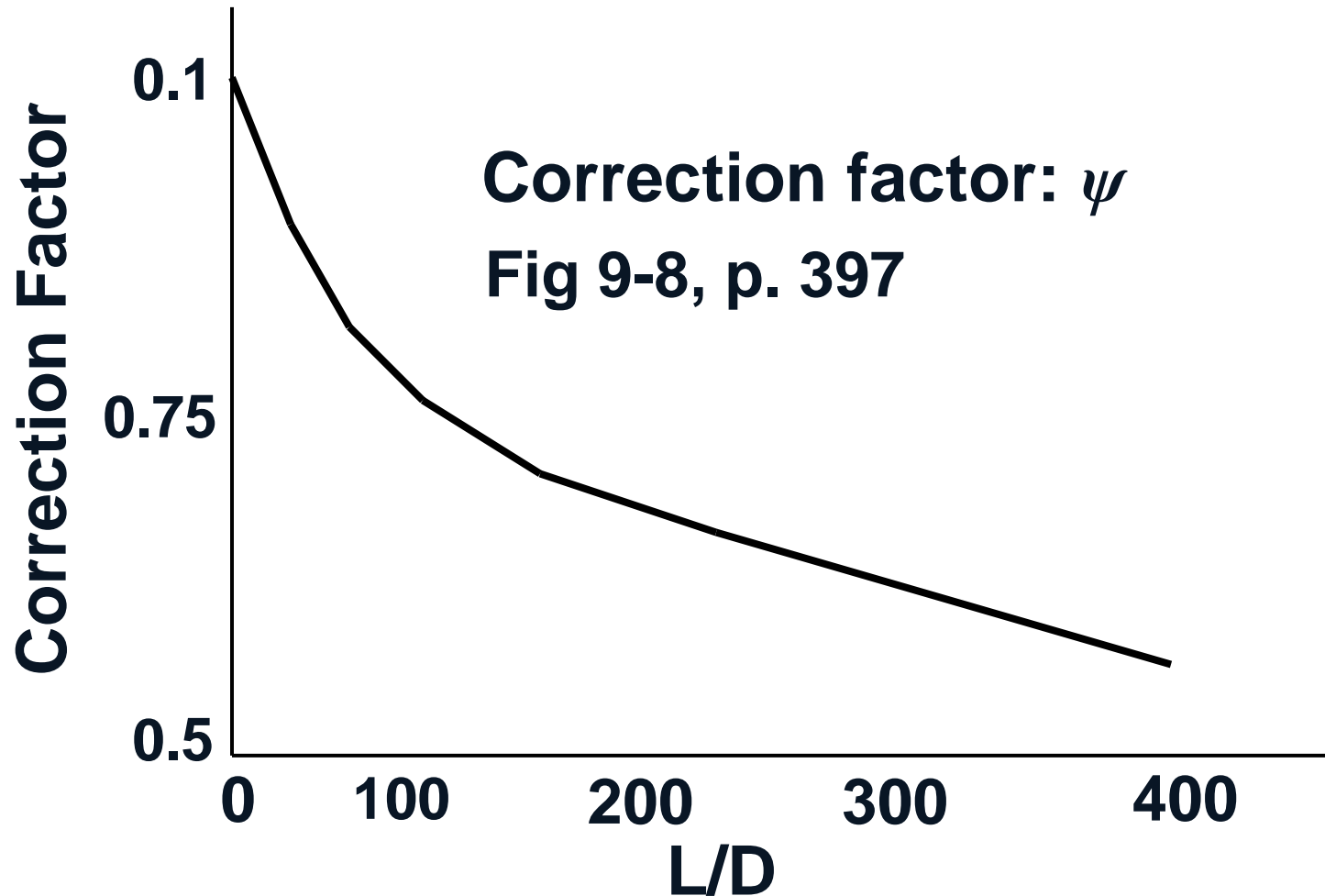
$$v_{fg} = \Delta \bar{V}^{fg}$$

- ✚ Mass flux with L/D correction factor, ψ , Fig 9-8, p. 397:

$$G_T = 0.9\psi \frac{\Delta H_v}{v_{fg}} \sqrt{\frac{g_c}{C_p T_s}}$$

Empirical 0.9 factor to match data for homogeneous venting

Correction for 2-f Flashing Flow in Pipes



Two-Phase Mass Discharge

✚ **Clausius Clapyron:** $\frac{dP}{dT} = \frac{\Delta H_v}{T v_{fg}}$

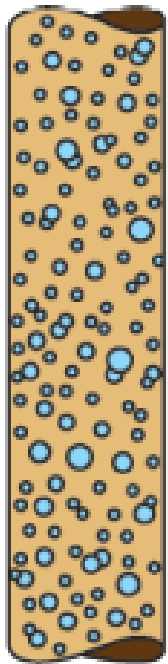
$$G_T = 0.9\psi \frac{\Delta P}{\Delta T} \sqrt{\frac{g_c T_s}{C_p}} \quad \psi = 1 \text{ for an orifice}$$

$$A = m_o \dot{q} / G_T \left(\sqrt{\frac{V}{m_o} \frac{\Delta H_v}{v_{fg}} + \sqrt{C_v \Delta T}} \right)^2 \quad m_o = \text{mass before release}$$

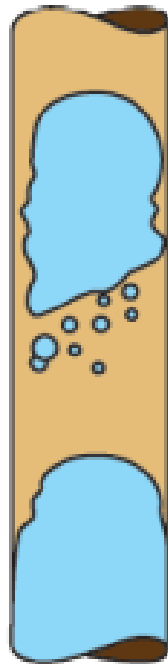
With CC equation:

$$A = m_o \dot{q} / G_T \left(\sqrt{\frac{V}{m_o} T_s \frac{dP}{dT} + \sqrt{C_v \Delta T}} \right)^2$$

Heat terms: \dot{q}
 generated by process,
 removed by discharge
 adsorbed by evaporate
 ΔT due to ΔP (OP)



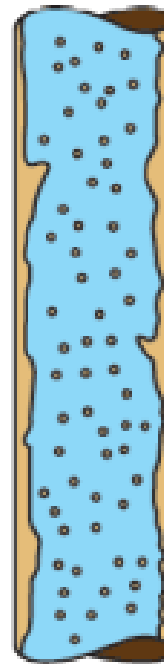
Bubble Flow



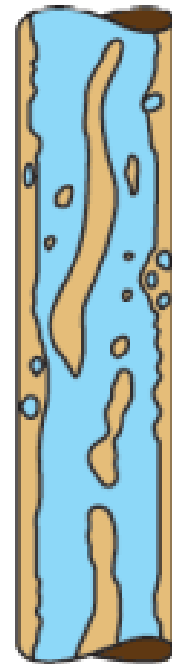
Slug or Plug Flow



Churn Flow



Annular Flow



Wispy Annular Flow

Patterns of two phase flow

Thermal Reaction Behavior

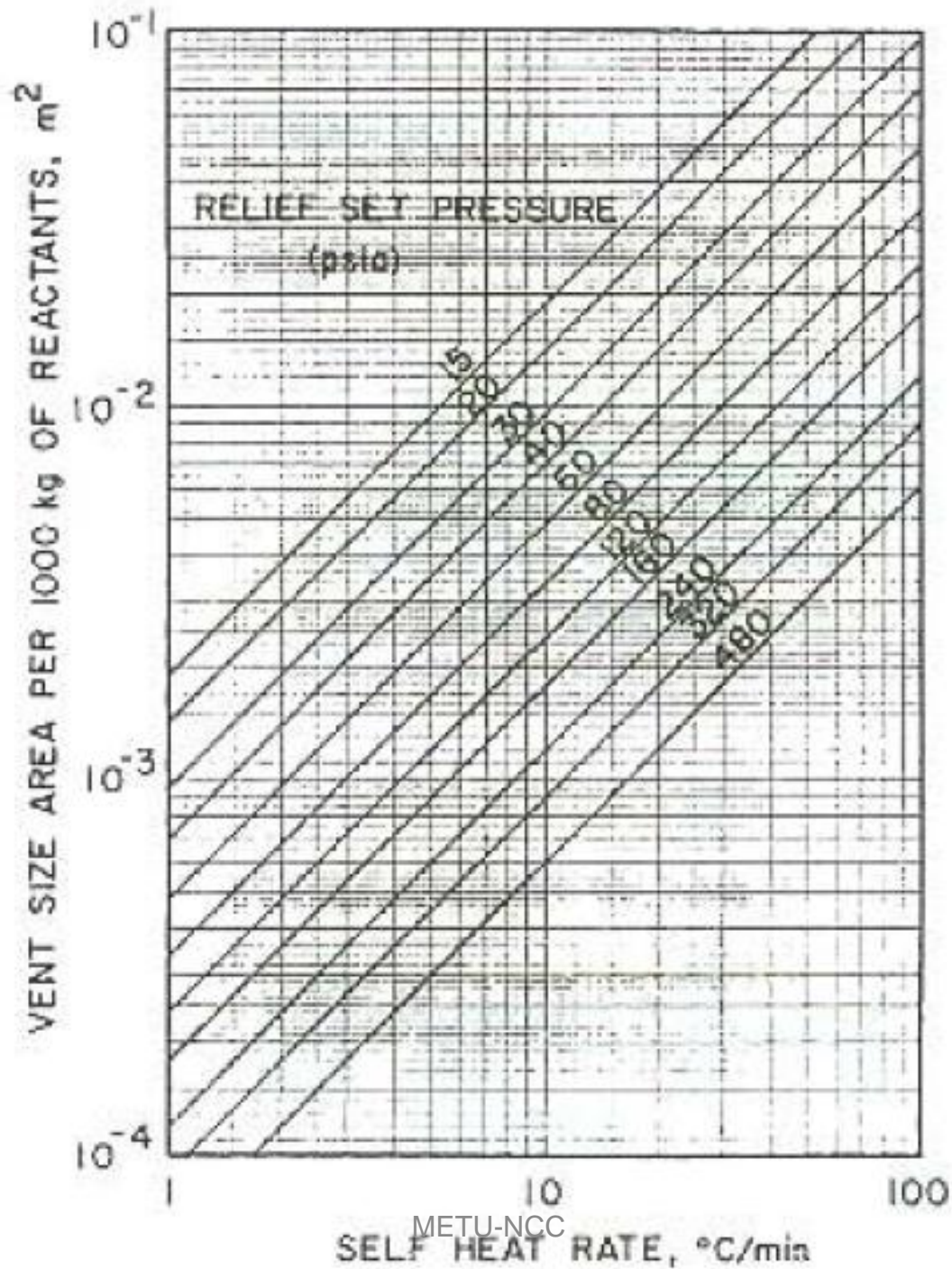
- ✚ Measure heat input rate using a calorimeter, such as VSP, Fig 8-8, p. 366

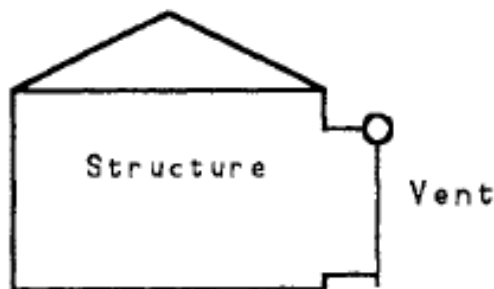
$$q = 0.5C_v \left[\left(\frac{dT}{dt} \right)_s + \left(\frac{dT}{dt} \right)_m \right]$$

- ✚ Measure heating rate at the set pressure and the heating rate at the maximum pressure
- ✚ Understand behavior of two-phase releases
- ✚ Avoid scenarios that can result in two-phase releases, e.g., overheated polymerization reactor

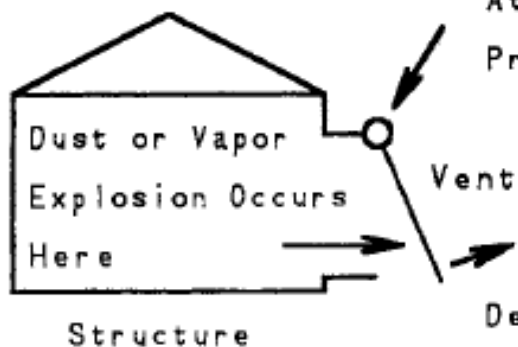
Nomograph Sizing Method

- ✚ A graphical method by Fauske for quick estimates of two-phase release areas uses only this information:
 - Heating rate at the set temperature, $(dT/dt)_s$
 - Set pressure
 - Mass of reactants
- ✚ Obtain a vent size area using Fig 9-9, p. 403
 - Assumes a discharge piping of $L/D = 400$ (a discharge coefficient = 0.5), and 20 % OP.
- ✚ Adjust an area estimate for other L/D ratios and OP values.





Normal Position of Vent



Attachment of Vent Prevents Projection of Vent Debris

Deflagration Vent Opens, Reducing Overpressure and Resulting Damage

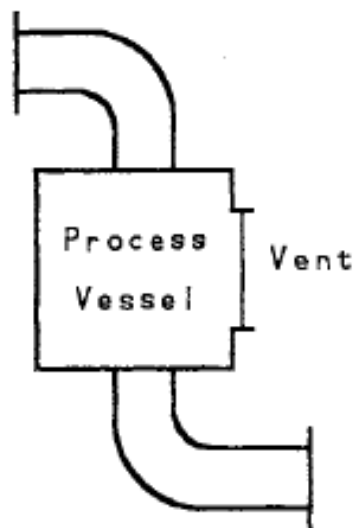


Figure 9-10 Deflagration vents for structures and process vessels.

9-6 Deflagration Venting for Dust and Vapor Explosions

○ Vents for Low-Pressure Structures

$$A = \frac{C_{\text{vent}}^* L_1 L_2}{\sqrt{P}} \quad \text{by Runes}$$

A is the required vent area,

C_{vent}^* is a constant that depends on the nature of the combustible material,

L_1 is the smallest dimension of the rectangular building structure to be vented,

L_2 is the second smallest dimension of the enclosure to be vented, and

P is the maximum internal pressure that can be withstood by the weakest member of the enclosure.

○ Vents for High-Pressure Structures

$$K_G \text{ or } K_{St} = \left(\frac{dP}{dt} \right)_{\max} V^{1/3}$$

K_G is the deflagration index for gases and vapors,

K_{st} is the deflagration index for dusts,

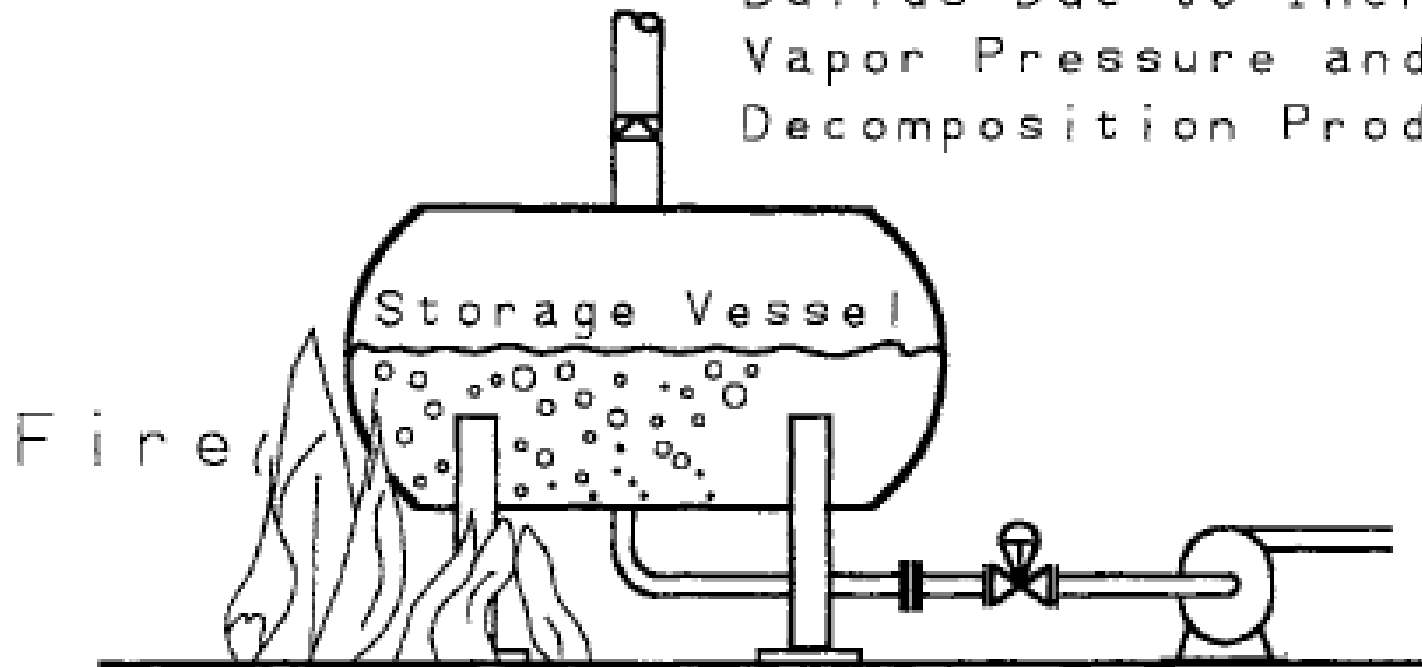
$(dP/dt)_{\max}$ is the maximum pressure increase, determined experimentally, and

V is the volume of the vessel.

Reliefs for Fired Reactors

- + Reactors exposed to external fires: heating and boiling of process liquids and excessive pressures**
- + Usually exposure at a small part of reactor surface: two-phase foam is smaller amount than from a runaway reaction**
- + Help prevent two-phase flow during external fire relief: allow a large vapor space above the liquid**
- + If reactor not protected, firing can lead to reactor failure and result in a BLEVE (p. 282) and if liquid is flammable, a VCE (p. 281)**
- + Security results more from inherently safer designs**

Pressure in Vessel
Builds Due to Increased
Vapor Pressure and/or
Decomposition Products



$$A = \frac{Q m_o v_{fg}}{G_T V \Delta H_v}$$

Q is the constant heat input rate,

G_T is the mass flux through the relief,

A is the area of the relief,

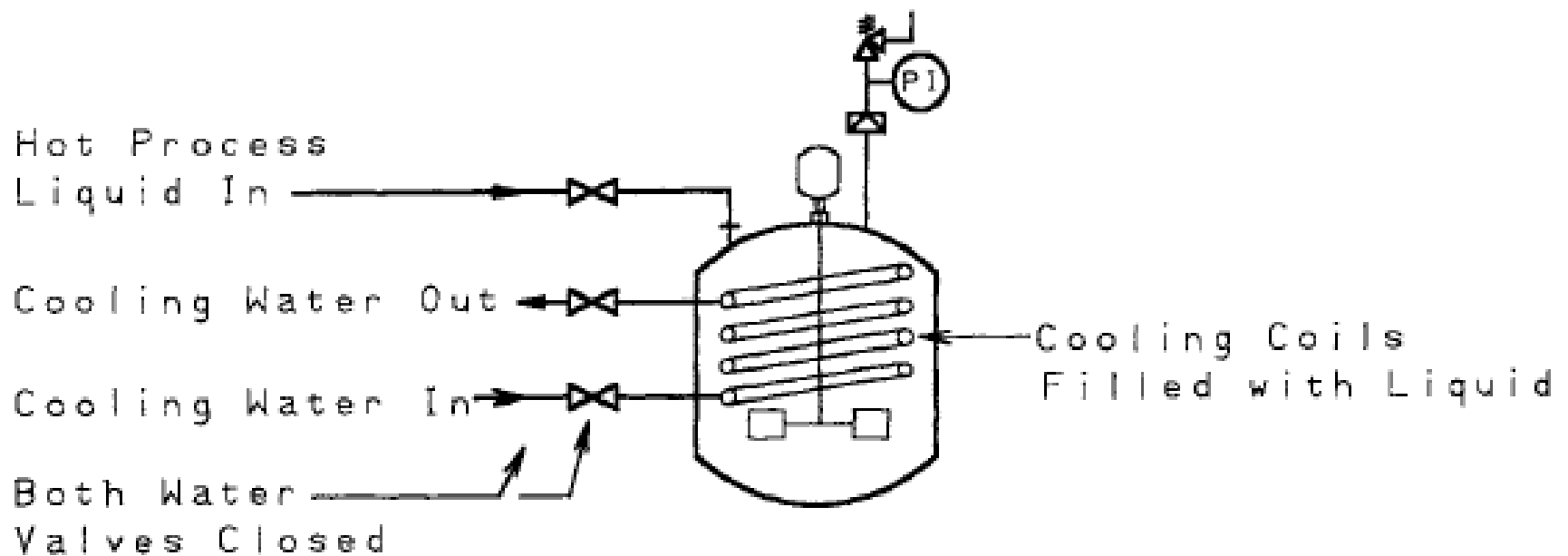
m_o is the liquid mass in the vessel,

V is the volume of the vessel,

ΔH_v is the heat of vaporization of the liquid.

Reliefs for Thermal Expansion of Process Fluids

- ✚ Liquids contained process piping expands and damage pipes & vessels
 - ✚ Ex; Cooling coil in reactor
 - ✚ Contamination of reactor
 - ✚ Subsequent corrosion
 - ✚ Substantial plant outage
 - ✚ Large repair expense



Heat Transfer from Hot Vessel Fluid to Cooling
Liquid Increases Cooling Liquid Temperature
Leading to Thermal Expansion.

Reliefs for Thermal Expansion of Process Fluids

$$\beta = \frac{1}{V} \left(\frac{dV}{dT} \right)$$

Then, the volumetric expansion rate is expressed

$$Q_v = \frac{dV}{dt} = \frac{dV}{dT} \frac{dT}{dt} = \beta V \left(\frac{dT}{dt} \right)$$

Energy balance with external heating

$$mC_P \frac{dT}{dt} = UA(T - T_a)$$

Reliefs for Thermal Expansion of Process Fluids

Then, the volumetric expansion rate is expressed

$$Q_v = \frac{\beta V}{m C_P} UA(T - T_a) = \frac{\beta}{\rho C_P} UA(T - T_a)$$

**Homework due on Jan/6(Thu)
Crowl, Problems 9-1, 2, 5, 19, 28**